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Luminescent silicon nanocrystals produced by near-infrared nanosecond pulsed laser ablation in water



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ABSTRACT

We report the investigation of luminescent nanoparticles produced by ns pulsed Nd:YAG laser ablation of silicon in water. Combined characterization by AFM and IR techniques proves that these nanoparticles have a mean size of \sim 3 nm and a core–shell structure consisting of a Si-nanocrystal surrounded by an oxide layer. Time resolved luminescence spectra evidence visible and UV emissions; a band around 1.9 eV originates from Si-nanocrystals, while two bands centered at 2.7 eV and 4.4 eV are associated with oxygen deficient centers in the SiO₂ shell.

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1. Introduction

The observation of photoluminescence (PL) in the visible is one of the most relevant effects induced by the reduction of Si down to nanoscale [1]. This feature, surprising for a not highly emissive bulk material, has attracted a wide interest motivated by the use in several application fields (optoelectronics, photovoltaics, bioimaging) [2-5], and has led the research towards the development of production methods able to finely control the physical and chemical properties of the nanostructured Si. To this purpose, laser ablation (LA) in liquids is particularly promising since it provides effective control parameters (laser photon energy, fluence, pulse duration, liquid reactivity) for the morphology and the structure of related products and, therefore, it has attracted much attention [6–10]. Previous works have demonstrated the viability of a green method to produce Si-nanocrystals (Si-NCs) by LA in water, and have addressed their luminescence properties [11–14]. Recently, it has also been achieved the bio-functionalization of LA induced Si-NCs thus opening the way to useful applications such as fluorescence imaging or drug delivery [15,16]. These studies evidence a rich phenomenology of emission features, dependent both on

the laser parameters and on the sample history (aging, oxidation effects, filtering treatments); however, the microscopic origin of the observed PL bands has not been clarified yet. One of the most debated questions concerns with the interplay between the intrinsic PL related to Si-NC and extrinsic PL associated with defects localized at the interface between Si and its environment [17]. To this aim, the combined use of a tunable excitation laser source and time resolved spectroscopy is useful to get a thorough understanding of the excitation/emission pathway: (i) to distinguish between electron hole radiative recombination processes and transitions localized at defect levels); (ii) to characterize the decay kinetics from the excited states. In the present work we investigate the PL of nanoparticles produced by LA of Si wafer in water using the first harmonic of a ns pulsed Nd:YAG laser. Our experimental approach is based on the use of time-resolved luminescence and complementary techniques to probe the morphological and structural properties, thus providing a solid support to discuss the origin of the observed PL bands.

2. Experimental methods

A n-type Si (100) wafer, with thickness of 0.5 mm, was used as target. It was ultrasonically rinsed in ethanol for 30 min and then immersed in 8 mL of de-ionized water. The first harmonic of a pulsed Nd:YAG laser (Quanta System SYL 201, $\lambda = 1064$ nm,

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repetition rate 10 Hz, pulse width 5 ns) was employed to irradiate the target at room temperature for 30 min. After focusing by a lens (150 mm focal length), the laser spot diameter on the target was $\sim\!1$ mm, and its energy density was $\sim\!0.6\,\text{J/cm}^2$ per pulse. During the laser irradiation a rotator stage moved the Si target thus avoiding the crater formation on its surface.

The as-prepared solution was placed in a quartz cuvette for the optical absorption (OA) and PL measurements, while a droplet $(\sim 50 \,\mu\text{L})$ was used for morphology and structure analysis. All the experiments to characterize the obtained solution were performed at room temperature within a day after ablation. OA measurements were carried out by a double beam spectrometer (JASCO V-560) with bandwidth of 5 nm; the spectra were corrected by subtracting the contribution of the cuvette and water. Time resolved PL spectra were carried out under a tunable laser excitation, provided by an optical parametric oscillator pumped by the III harmonic (3.49 eV) of a Nd:YAG laser (pulse width ~5 ns, repetition rate 10 Hz). The emitted light was spectrally resolved by a grating (150 grooves mm⁻¹ and 300 nm blaze), and then acquired by an intensified CCD camera driven by a delay generator (PI MAX Princeton Instruments) setting the acquisition time window, W_T , and the delay, T_D , with respect to the arrival of laser pulses. All the emission spectra were detected with a bandwidth of 10 nm and corrected for the monochromator dispersion. The photoluminescence excitation (PLE) spectra were measured manually point-by-point by tuning the laser and recording the PL intensity. Each point is normalized to the laser-pulse energy; its value is affected by an uncertainty of \sim 10% mainly due to the power laser fluctuations. Atomic force microscopy (AFM) measurements were performed in the tapping mode by a Multimode V (Veeco Metrology) scanning probe microscope. PointProbe Plus Silicon probes were used with Al backside reflex coating, resonance frequency of 300 kHz and a tip radius <10 nm. All the images were acquired on the dried droplet deposited onto a mica substrate by a scan window of $2 \mu m \times 2 \mu m$. Since the de-ionized water contains a limited number of particles of unknown origin with diameter of \sim 1 nm, in the study of the size distribution of the nanoparticles produced by LA, all the objects with diameters lower than \sim 2 nm were systematically rejected. Confocal microscopy-Raman spectra were performed by a (Bruker SENTERRA) spectrometer ($\lambda = 532 \, \text{nm}$, power $\sim 20 \, \text{mW}$), supplied with a CCD camera and a microtranslation stage, the spectral resolution being 3 cm⁻¹. Infrared (IR) absorption was measured by a Fourier-transform spectrometer (Bruker Vertex 70), with spectral resolution of 0.5 cm⁻¹. The spectra were obtained as difference between the absorption detected in a pellet (thickness of 1 mm) of

LA induced nanoparticles dispersed in KBr powder and a reference of KBr.

3. Results and discussion

Morphologic properties of LA induced nanoparticles from a Si target in water are displayed by the AFM image of Fig. 1. Si-NCs are dispersed, their size distribution, obtained by counting $\sim\!250$ particles, is reported in the histogram: it is peaked around $\sim\!3$ nm, the half width at half maximum (HWHM) is $\sim\!1$ nm. This finding is in good agreement with the sizes of single Si-NCs measured by high resolution transmission electron microscope (TEM) after LA performed at λ = 1064 nm with energy density of \sim 4.7 J/cm² [13]. However, we note that in those experiments the Si-NCs appear to be aggregates of 10–20 nm; the difference with our sample, consisting of non-aggregated Si-NCs, could be due to the lower energy density $(\sim\!0.6]/\text{cm}^2)$ used in the present work.

The structural and optical properties of these nanoparticles are shown in Fig. 2. Si-NCs are identified by the Raman line at $518 \, \mathrm{cm}^{-1}$, Fig. 2(a); its redshift ($\Delta \nu = -2.2 \pm 0.2 \, \mathrm{cm}^{-1}$) and broadening respect to the lineshape related to a bulk Si crystal agree with the phonon confinement effect [18]. The dependence of the peak shift on the Si-NC size (d in nm) is given by the following phenomenological law [19]:

$$\Delta v = -\frac{19.856}{d^{1.586}} \tag{1}$$

So, we can indirectly measure the mean size that results to be $\sim\!\!4.0\,\mathrm{nm}$ and agrees with the size distribution obtained by AFM analysis. The IR absorption in Fig. 2(b) evidences three bands characteristics of amorphous SiO₂ (silica). They are indeed assigned to the Si–O–Si bond-rocking ($\sim\!470\,\mathrm{cm}^{-1}$), Si–O–Si bondbending ($\sim\!800\,\mathrm{cm}^{-1}$) and Si–O–Si asymmetric bond-stretching ($\sim\!1100\,\mathrm{cm}^{-1}$) [20]. These findings agree with the oxidation of Si-NC surface and the formation of a Si/SiO₂ core–shell structure [5]. The absorption spectrum in the visible and UV range is shown in Fig. 2(c): it increases monotonically with photon energy and evidences a shoulder below 3.0 eV. In agreement with previous studies [5], these features provide further support to the fabrication of Si-NCs.

The PL spectrum of Fig. 3(a) shows a band peaked at 1.95 ± 0.04 eV with a FWHM of 0.57 ± 0.05 eV. Its decay kinetics, monitored at 1.95 eV and displayed in the inset of Fig. 3(a), occurs in the μ s timescale. The lifetime, measured as the time necessary to reduce the PL intensity by a factor of e, is $\tau = 10 \pm 1$ μ s. The PLE

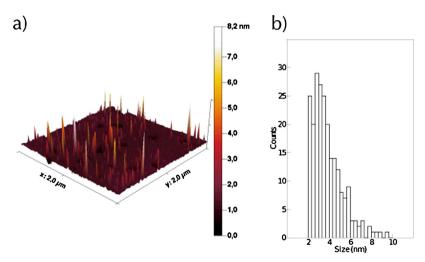


Fig. 1. AFM topographic image ($2 \mu m \times 2 \mu m$ scan) of LA-produced nanoparticles (a) and their size distribution (b).

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